

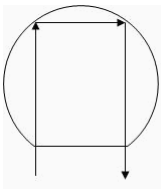
Part Number

Customer

Category	Parameter	Specification	Measurement Method
OverallWafer	1.0	Diameter	150.00 +/- 0.20 mm
	2.0	Primary Flat Orientation	{110} +/- 0.5 degree
	3.0	Primary Flat Length	57.50 +/- 2.50 mm
	4.0	Secondary Flat Orientation	none
	5.0	Overall Thickness	461.00 +/- 6.00 µm
	6.0	Total Thickness Variation (TTV)	<5.00µm
	7.0	Bow	<60.00µm
	8.0	Warp	<60.00µm
	9.0	Edge Chips	0
	10.0	Edge Exclusion	5mm
HandleSilicon	11.0	Handle Growth Method	CZ
	12.0	Handle Orientation	{100} +/- 0.5 degree
	13.0	Handle Thickness	400.00 +/- 5.00 µm
	14.0	Handle Doping Type	P
	15.0	Handle Dopant	Boron
	16.0	Handle Resistivity	3~5 Ohmcm
	17.0	Backside Finish	Polished with light handling marks. Oxide and laser marking
	18.0	Backside Lasermark	IceMOS standard
BuriedOxide	19.0	Oxide Type	Thermal
	20.0	Oxide Thickness	10,000.00 +/- 500.00 Å
	21.0	Oxide formed on	Handle and/or Device Wafer
DeviceSilicon	22.0	Device Growth Method	CZ
	23.0	Device Orientation	{100} +/- 0.5 degree
	24.0	Nominal Thickness	60.00 +/- 0.70 µm
	25.0	Distance to device silicon edge from wafer edge	<= 2mm
	26.0	Device Doping Type	P
	27.0	Device Dopant	Boron
	28.0	Device Resistivity	3 ~ 5 Ohmcm
	29.0	Voids	none
	30.0	Scratches	0
	31.0	Haze	none
	32.0	Top surface Surface Average roughness, Ra	<0.5nm

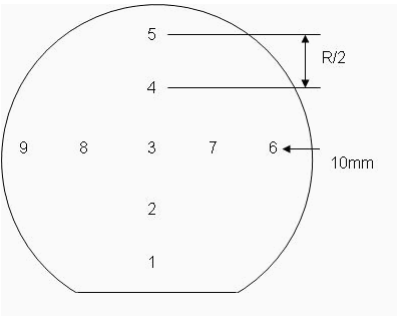
Part Number	Customer
-------------	----------

Category	Parameter	Specification	Measurement Method
----------	-----------	---------------	--------------------

Shipping Details	Wafer per box :	Max 25	
	Packaging :	Taped Polypropylene Wafer Box Empak, Ultrapak, 150.00mm Antistatic Double Bagging	
	Lot Shipment Data	Device Thickness Bow / Warp Data Handle and SOI Thickness	
Explanatory Notes	1. Microscope inspection performed using microscope scan as below. 5x objective.		

2. All bright light inspections performed exclude all wafer area outside the edge exclusion defined in Overall Wafer, Edge Exclusion. High intensity bright lamp inspection as per ASTM F523.

3. 9 point measurement are as shown in the diagram below:



Additional Information